



Attorney Docket No.: 002818/PDD/PSI/MBE

PATENT # 2811

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Suketu A. Parikh ✓

Serial No.: 09/244,788 ✓

Filed: 2/5/99 ✓

For: Dual Damascene Misalignment  
Tolerant Techniques For Vias And  
Sacrificial Etch Segments ✓

) Group:  
) Art Unit: 2811  
) Examiner:  
)  
) TRANSMITTAL LETTER  
)  
) PATENT COUNSEL  
) APPLIED MATERIALS, INC.  
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) Santa Clara, CA 95052

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

TRANSMITTAL OF FORMAL DRAWINGS

Enclosed please find twenty one (21) sheets of formal drawings for the above-identified patent application.

Dated: 8/9/99

Respectfully submitted,

By:

Robert W. Mulcahy  
Reg. No.: 25,436

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